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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Applicant Patricia B. Smith, et al.

Docket Number: TI-29811

Serial No.: 09/975,639

Art Unit: 2818

Filed: 10/11/01

Examiner: Quoc D. Hoang

For: Hydrogen Plasma Photoresist Strip and Polymeric Residue  
Cleanup Process for Low Dielectric Constant Materials

CERTIFICATION OF FACSIMILE TRANSMISSION

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Karen Vertz  
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12-23-04  
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FACSIMILE COVER SHEET

<input checked="" type="checkbox"/> FACSIMILE COVER SHEET	<input type="checkbox"/> AMENDMENT (# Pages)
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<input type="checkbox"/> ASSIGNMENT	<input type="checkbox"/> APPEAL (# Pages)
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<input type="checkbox"/> CONTINUATION APP'N	<input type="checkbox"/> ELECTION
<input type="checkbox"/> DIVISIONAL APP'N	
NAME OF INVENTOR(S): Patricia B. Smith, et al.	
RECEIPT DATE & SERIAL NO.: Serial No.: 09/975,639 Filing Date: 10/11/01	
TITLE OF INVENTION: Hydrogen Plasma Photoresist Strip and Polymeric Residue Cleanup Process for Low Dielectric Constant Materials	
TI FILE NO.: TI-29811	DEPOSIT ACCT. NO.: 20-0668
FAXED: 12-23-04 DUE: 1-1-05 ATTY/SECY: RAK/kjv	

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Dallas, TX 75265-6474

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Patricia B. Smith, et al.

Serial No.: 09/975,639

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For: Hydrogen Plasma Photoresist Strip and Polymeric Residue Cleanup Process for Low Dielectric Constant Materials

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NOTICE OF APPEAL FROM THE PRIMARY EXAMINER TO THE BOARD OF APPEALS

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

CERTIFICATION OF FACSIMILE TRANSMISSION	
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<u>Karen Vertz</u> Karen Vertz	<u>12-23-04</u> Date

Applicant hereby appeals claims 1, 5-13, 30-39 and 60-68 to the Board of Appeals from the decision dated October 1, 2004 of the Primary Examiner finally rejecting claims 1, 5-13, 30-39 and 60-68.

The item(s) checked below are appropriate:

1. ☐ An extension of time to respond to the final rejection  
☐ was granted on \_\_\_\_.  
☐ is requested for \_\_\_\_ month(s).
2. ☐ A timely response to the final rejection has been filed, as provided in 841 O.G. 1411.
3. ☒ Fee \$500.00:  
☐ Not required (Fee paid in prior appeal)  
☒ The Commissioner of Patents is hereby authorized to charge any fees which may be required, or credit any overpayment to Deposit Account No. 20-0668 of Texas Instruments Incorporated.

Signature [Rule 191(b)]

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